

INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Application No.	10/815,905
	Filing Date	March 31, 2004
	First Named Inventor	Lin et al.
	Art Unit	2874
(Multiple sheets used when necessary)	Examiner	Hoang Q. Tran
SHEET 1 OF 3	Attorney Docket No.	QCO.094A/061113

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1	5,218,472	06/00/1993	Jozefowicz et al.	
	2	5,488,505	1/30/1996	Engle	
	3	5,578,976	11/26/1996	Yao	
	4	5,737,050	4/7/1998	Takahara et al.	
	5	5,771,321	6/23/1998	Stern	
	6	5,784,189	7/21/1998	Bozler et al.	
	7	5,835,256	11/10/1998	Huibers	
	8	5,967,163	10/19/1999	Pan et al.	
	9	6,031,653	2/29/2000	Yu	
	10	6,088,162	7/11/2000	Someno	
	11	6,097,145	8/1/2000	Kastalsky et al.	
	12	6,137,150	10/24/2000	Takeuchi et al.	
	13	6,333,556	12/25/2001	Juengling et al.	
	14	6,452,124	9/17/2002	York et al.	
	15	6,624,944	9/23/2003	Wallace et al.	
	16	6,639,724	10/28/2003	Bower et al.	
	17	6,653,997	11/25/2003	Van Gorkom et al.	
	18	6,791,441	9/14/2004	Pillans et al.	
	19	6,844,959	1/18/2005	Huibers et al.	
	20	6,906,847	6/14/2005	Huibers et al.	
	21	6,940,631	9/6/2005	Ishikawa	
	22	7,016,099	3/21/2006	Ikeda et al	
	23	7,078,293	7/18/2006	Lin et al.	
	24	7,110,158	9/19/2006	Miles	
	25	7,123,216	10/17/2006	Miles	
	26	7,172,915	2/6/2007	Lin et al.	
	27	7,250,315	7/31/2007	Miles	
	28	2001-0010953	8/2/2001	Kang et al.	
	29	2001-0055208	12/27/2001	Kimura	

Examiner Signature

Date Considered

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	30	2002-0058422	05/00/1001	Jang et al.	
	31	2002-0109899	8/15/2002	Ohtaka et al.	
	32	2002-0195681	12/26/2002	Melendez et al.	
	33	2003-0007107	1/9/2003	Chae	
	34	2003-0021004	1/30/2003	Cunningham et al.	
	35	2003-0077843	4/24/2003	Yamauchi et al.	
	36	2003-0102771	6/5/2003	Akiba et al.	
	37	2003-0132822	7/17/2003	Ko et al.	
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	39	2006-0066935	3/30/2006	Cummings et al.	
	40	2006-0261330	11/23/2006	Miles	

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	41	EP 1 243 550	9/25/2002	Xerox		
	42	JP 09-036387	2/7/1997	Denso Corp.		X-abstract
	43	JP 10-116996	5/6/1998	Texas Instruments Japan		X
	44	JP 2002-341267	11/27/2002	Sony Corp		X-abstract
	45	JP 2003-057571	2/26/2003	Sony Corp		X-abstract
	46	JP 06-281956	10/7/1994	Sharp		X
	47	JP 07-45550	2/14/1995	Yamanouchi		X
	48	JP 2000-075223	3/14/2000	Seiko Epson Corp.		X

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	49	Kawamura et al., Fabrication of fine metal microstructures packaged in the bonded glass substrates, Proceedings of SPIE, vol. 3893, pp. 486-493, 1999	
	50	Office Action dated June 9, 2006 in Chinese App. No. 09158928.6, Docket No. QCO.094VCN	

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	51	Office Action dated received December 29, 2006 in Chinese App. No. 09158928.6, Docket No. QCO.094VCN	
	52	Office Action dated March 30, 2007 in Chinese App. No. 09158928.6, Docket No. QCO.094VCN	
	53	Notification of Reason for Rejection dated August 8, 2006 in Japanese App. No. 2004-100510, Docket No. QCO.095VJP	
	54	Office Action dated January 31, 2006 in Korean App. No. 10-2004-0036474, Docket No. QCO.094VKR	

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